



DOCKET NO: 213345US90CONT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
KANEFUMI NAKAHARA, ET AL. : EXAMINER: KIM, P
SERIAL NO: 09/935,734 :
FILED: AUGUST 24, 2001 : GROUP ART UNIT: 2851
FOR: EXPOSURE APPARATUS, :
LITHOGRAPHY SYSTEM AND :
CONVEYING METHOD, AND DEVICE :
MANUFACTURING METHOD AND :
DEVICE :

RECEIVED
JUL 31 2003
TECHNOLOGY CENTER 2800

AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated January 30, 2003, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 15 of this paper.